## AMENDMENT TO THE SPECIFICATION

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Please replace paragraph [0005] with new paragraph [0005], shown below.	
[0005] U.S. Patent Application No. [	], 10/002,035 entitled APPARATUS
AND METHOD FOR ATMOSPHERIC PRESSUR	E REACTIVE ATOM PLASMA PROCESSING
FOR SHAPING OF DAMAGE FREE SURFACES, inventor, Jeffrey W. Carr, filed November 1,	
2001 (Attorney Docket No. PANA-01000US1).	